

Search Notes

Application/Control No.

10/084,311

Examiner

Jacob Meek

Applicant(s)/Patent under
Reexamination

SARUWATARI, EIJI

Art Unit

2611

SEARCHED

Class	Subclass	Date	Examiner
398	202,207 26,27,38 208,209	11/21/2005	JM
375	222	11/21/2005	JM
704	233	11/21/2005	JM
379	56.3,416	11/21/2005	JM
379	392.01	11/21/2005	JM
398	131,208	11/21/2005	JM
455	296,570	11/21/2005	JM

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
375	227	3/22/2006	JM
375	317	3/22/2006	JM
398	26,27,38	3/22/2006	JM

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East: See search notes	3/22/2006	JM
NPL	11/21/2005	JM
398/26,27,38 per Jason Chen	11/21/2005	JM